



**LAM Research**

**490 AutoEtch Plasma Etch  
150mm Configuration**

**Serial NR: 1694**

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### LAM 490 AutoEtcher

- Polysilicon: 490
- Wafer size: 6 inch
- Upgraded TFT monitors
- Wafer detection
- Incl maintenance console
- Conditon: "AS IS" (No chiller and no pump, but with ENI RF Generator)

#### Features:

- Single-wafer processing
- Fully automated microprocessor control
- Cassette-to-cassette wafer processing
- Vacuum load locked
- Programmable, variable electrode spacing
- Endpoint detection
- Configurable for 3-inch to 6-inch wafers
- Stand-alone or bulk-head mount configuration

